



**ELECTRONIC COPY**

LG785614745  
Report verification at igi.org



March 24, 2026

IGI Report Number **LG785614745**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL POLYGON STEP CUT**

Measurements **11.84 X 8.14 X 5.64 MM**

**GRADING RESULTS**

Carat Weight **4.01 CARATS**

Color Grade **D**

Clarity Grade **INTERNALLY FLAWLESS**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

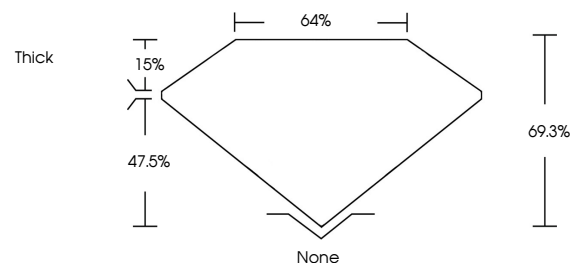
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG785614745**

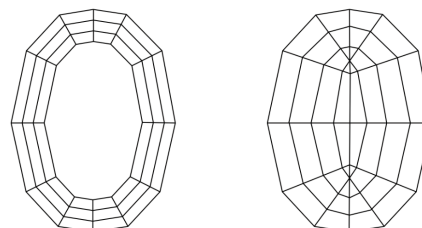
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

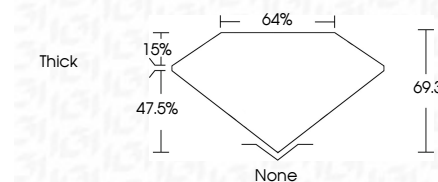
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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OVAL POLYGON STEP CUT

11.84 X 8.14 X 5.64 MM

4.01 CARATS

D

Color Grade **D**

Clarity Grade **IF**

Table **69.3%**

Girdle **4.5%**

Thick **15%**

Culet **None**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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